

THE INVENTION CLAIMED IS:

1. An apparatus adapted to scrub a substrate,
comprising:

5 a plurality of rollers adapted to rotationally
support a substrate in a substantially vertical orientation;
and

at least one brush member positioned to contact an
edge bevel of the substrate with a stationary surface of the
10 brush member at a location between two of the rollers.

2. An apparatus adapted to scrub a substrate,
comprising:

a plurality of rollers adapted to rotationally
15 support a substrate in a substantially vertical orientation;
a finger having a first end extending away from the
substrate, a second end extending toward the substrate, and a
central portion between the first end and the second end, the
finger being pivotally mounted at the central portion; and

20 a brush member mounted on the second end of the
finger and in contact with an edge bevel of the substrate.